

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Masato Yonezawa et al. Art Unit : Unknown
Serial No. : New Continuation Application Examiner : Unknown
Filed : February 11, 2004
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Under 35 USC §120, this application relies on the earlier filing date of application serial number 10/117,348, filed on April 8, 2002. The attached list of references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,


John F. Hayden
Reg. No. 37,640

Date: February 11, 2004

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 12732-098002		Application No. New Continuation Application	
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Masato Yonezawa et al.					
		Filing Date February 11, 2004		Group Art Unit			

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,262,654	11/16/1993	Yamazaki			11/15/1991
	AB	5,627,364	05/06/1997	Codama et al.			10/10/1995
	AC	6,023,257	02/08/2000	Koyama			11/14/1995
	AD	6,082,865	07/04/2000	Yamazaki			07/22/1998
	AE	6,087,648	07/11/2000	Zhang et al.			06/26/1998
	AF	6,194,740	02/27/2001	Zhang et al.			07/15/1998
	AG	6,236,063	05/22/2001	Yamazaki et al.			05/11/1999
	AH	6,243,155	06/05/2001	Zhang et al.			10/19/1998
	AI	6,255,705	07/03/2001	Zhang et al.			09/22/1998
	AJ	6,274,861	08/14/2001	Zhang et al.			06/09/2000
	AK	6,287,888	09/11/2001	Sakakura et al.			12/23/1998
	AL	6,288,388	09/11/2001	Zhang et al.			09/24/1998
	AM	US 2001/0000676 A1	05/03/2001	Zhang et al.			12/29/2000
	AN	US 2001/0019130 A1	09/06/2001	Yamazaki et al.			03/15/2001
	AO	US 2001/0030279 A1	10/18/2001	Zhang et al.			06/15/2001
	AP	US 2001/0030704 A1	10/18/2001	Kimura			04/09/2001
	AQ	US 2001/0031074 A1	10/18/2001	Yamazaki et al.			04/13/2001
	AR	US 2001/0038065 A1	11/08/2001	Kimura			05/08/2001
	AS	US 2002/0000631 A1	01/03/2002	Sakakura et al.			08/28/2001
	AT	US 2002/0011972 A1	01/31/2002	Yamazaki et al.			01/17/2001
	AU	US 2002/0011978 A1	01/31/2002	Yamazaki et al.			06/04/2001
	AV	US 2002/0012057 A1	01/31/2002	Kimura			05/25/2001
	AW	US 2002/0027229 A1	03/07/2002	Yamazaki et al.			06/11/2001
	AX	US 2002/0044208 A1	04/18/2002	Yamazaki et al.			08/08/2001

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	